

Form PTO-1449 U.S. DEPARTMENT OF  
COMMERCE (REV. 7-80) PATENT AND TRADEMARK OFFICE

DOCKET NO.  
NL 000044

Serial No.

Applicant  
MARTIN H. BLEES

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**INFORMATION DISCLOSURE CITATION**  
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**U.S. PATENT DOCUMENTS**

Ex. Int.		Document Number	Date	Name	Class	Sub-class	Filing Date If Approp.
	AA						
	AB						
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	AE						
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**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub-Class	Trans.
							Yes
	AG						
	AH						
	AI						
	AJ						
	AK						

**OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)**

RF	AK	"Soft Lithography" by Y. Xia et al., Angew. Chem. Int. Ed. 1998, Vol. 37, pages 551-575.	Date Considered 8-30-2002
	AL		
	AM		
Examiner <u>Ram Naresh</u>		Date Considered 8-30-2002	
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JC914 U.S. PTO  
09/759179  
01/12/01



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DOCKET NO.  
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**U.S. PATENT DOCUMENTS**

Ex. Int.		Document Number							Date	Name	Class	Sub-class	Filing Date If Approp.
PK	AA	4	0	4	1	1	1	4	8/9/77	YEVICK	264	1	7/3/75
PK	AB	5	5	2	1	0	3	0	5/28/96	McGREW	430	1	6/6/95
PK	AC	5	9	0	0	1	6	0	5/4/99	WHITESIDES ET AL	216	41	7/9/96
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**FOREIGN PATENT DOCUMENTS**

		Document Number							Date	Country	Class	Sub-Class	Trans.
	AF												Yes
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	AH												
	AI												
	AJ												

**OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)**

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Examiner <i>Ramnath</i>		Date Considered <i>8-30-2002</i>
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